

# Preview

- Job Description

- **Job Title:** Experienced Researcher
- **Job Summary:** Electron Beam Lithography Research and Operation
- **Job Description:** Expert in Ebeam tool operation / Nanolithography/resist processing to contribute in extending the existing expertise in the field of nanofabrication and nanolithography using the new ebeam tool
- **Main Research Field:** Engineering

- FP7 / PEOPLE / Marie Curie Actions

**Research Framework Programme**  
**/ Marie Curie Actions: FP7**

- Job Details

- **Type of Contract:** Temporary
- **Status:** Fulltime
- **Hours Per Week:** 40
- **Company/Institute:** Institute of Microelectronics , NCSR Demokritos
- **Country:** GREECE
- **State/Province:** Attiki
- **City:** Athens

- Organisation/Institute Contact Data

- **Organisation:** NCSR Demokritos
- **Organisation/Institution Type:** Research Laboratory
- **Faculty/Department/Research Lab:** Institute of Microelectronics
- **Country:** GREECE
- **City:** Athens
- **Postal Code:** 15310
- **Street:** Patriarchou Gregoriou and Neapoleos
- **Email:** glezos@imel.demokritos.gr
- **Phone:** +30 210 6503236

- Application Details

- **Job Starting Date:** 01/09/2010
- **Application Deadline:** 10/07/2010
- **How To Apply:** Other

- Required Education Level

- **Required Education Level 1**
- **Degree:** PhD or equivalent
- **Degree Field:** Engineering

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- **Required Languages**

- **Required Languages 1**
- **Language:** ENGLISH
- **Language Level:** Excellent